



Patent No.: 56937-043

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Satoru TOMEKAWA, et al.

Serial No.: 09/998,327

Filed: December 03, 2001

For: CIRCUIT SUBSTRATE AND MANUFACTURING METHOD THEREOF

Group Art Unit: 2822

Examiner: Monica LEWIS

7/18/02  
7/20/02  
A.Well  
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**RESPONSE TO RESTRICTION REQUIREMENT**

Assistant Commissioner of Patents  
Washington, DC 20231

Sir:

In response to the Office Action of June 18, 2002 wherein restriction has been required, Applicants hereby elect Group I (claims 1-9) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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